Electrochemical deposition of mesoporous high-entropy Pt-Pd-Rh-Ru-Cu-Au-Se-Mo films

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Bottom-up approaches have been widely used to design nanoarchitectured metallic materials for various applications such as catalysis and biosensors. High-entropy materials (HEMs), characterized by their high configurational entropy, provide numerous active sites for complex multielectron reactions, which enhances catalytic performance. However, conventional methods for synthesizing nano-sized HEMs often require high-temperature calcination or environmentally unfriendly organic solvents. For the first time, we have synthesized mesoporous high-entropy metal films using a predominantly aqueous-based room-temperature electrodeposition method. It is crucial to assemble more metallic elements arbitrarily and to study the effects of different synthesis conditions on composition and entropy, which is rarely reported.

In this study, we developed a mesoporous high-entropy metal chalcogenides film containing eight elements (Pt, Pd, Rh, Ru, Cu, Au, Se, and Mo) through a soft-template-assisted electrochemical reduction method (Fig. We found that altering electrodeposition potential can regulate the metal composition and entropy, with the maximum entropy value reaching 1.95*R*. This value represents the highest reported for mesoporous metal-based materials to date. The uniformly

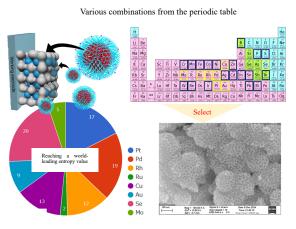


Fig. 1 Synthesis mechanism, elemental selection, molar ratios, and SEM image of high-entropy Pt-Pd-Rh-Ru-Cu-Au-Se-Mo.

distributed mesopores contribute to a substantial increase in surface area, facilitating enhanced catalytic activity. Our method, coupled with the use of a cost-effective carbon paper substrate, not only addresses economic challenges but also provides a platform for fabricating a wide range of HEMs with tailored properties.

1) Y. Kang et al., Nat. Commun 2023, 14: 4182. 2) L. Fu et al., ACS Nano 2024, 18, 27617–27629.